



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

The application of : Confirmation No. 5534

Masayoshi HIROSE et al. : Docket No. 2001-0386

Serial No. 09/821,046 : Group Art Unit 3724

Filed February 28, 2002 : Examiner Timothy V. Eley

POLISHING APPARATUS INCLUDING
TURNTABLE WITH POLISHING SURFACE
OF DIFFERENT HEIGHTS : **MAIL STOP: AMENDMENT**

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of March 23, 2005, the period for response to which having been extended by one month to July 23, 2005, kindly amend the above-referenced U.S. patent application as follows: